



**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re the Application of: **Ken SAWADA et al.**

Group Art Unit: **1709**

Application Number: **10/804,179**

Examiner: **Mohammad Eslamy**

Filed: **March 19, 2004**

Confirmation Number: **6768**

For: **RESIST PATTERN FORMING METHOD AND  
SEMICONDUCTOR DEVICE FABRICATION METHOD**

Attorney Docket Number: **042256**

Customer Number: **38834**

**AMENDMENT**

Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

August 10, 2007

Sir:

This paper is filed in response to the Office Action dated March 22, 2007, the response due date extended to August 22, 2007 by a two-months Extension of Time.

**Amendments to the Claims** begin on page 2 of this paper.

**Remarks** begin on page 9 of this paper.